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[10191/3980]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : LAERMER et al.
Serial No. : 10/519,724
Filing Date : December 28, 2004
For : DEVICE AND METHOD FOR PRODUCING CHLORINE
TRIFLUORIDE AND SYSTEM FOR ETCHING
SEMICONDUCTOR SUBSTRATES USING THIS DEVICE
Group Art Unit : 1763
Examiner : Dhingra, Rakesh Kumar

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date:

July 30, 2007

Signature:

Gerard A. Messina

Alexandria, VA 22313-1450

TRANSMITTAL

SIR:

Please find an Amendment transmitted herewith for filing in the above-identified patent application.

Additionally, a Supplemental Information Disclosure Statement accompanies this Amendment.

Applicants hereby requests a one-month extension of time for responding to the Office Action of March 28, 2007. The extended period for response expires on July 28, 2007. Please charge the \$120.00 extension fee and any other fee that may be required to Deposit Account No. 11-0600. A duplicate of this Transmittal is enclosed.

Respectfully submitted,

KENYON & KENYON LLP

Dated:

July 30, 2007

By:

Gerard A. Messina
Gerard A. Messina
Reg. No. 35,952
One Broadway
New York, NY 10004
(212) 425-7200

Handwritten signature of Gerard A. Messina.

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